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PATENT Customer No. 22,852 Attorney Docket No. 02887.0259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	application of:)	
Junji SUGAMOTO et al.)	Group Art Unit: 2891
Application No.: 10/706,090)	Examiner: Smith, Bradley
Filed:	November 13, 2003)	Confirmation No. 7292
For:	SEMICONDUCTOR WAFER TREATMENT METHOD, SEMICONDUCTOR WAFER INSPECTION METHOD, SEMICONDUCTOR DEVICE DEVELOPMENT METHOD AND SEMICONDUCTOR WAFER TREATMENT APPARATUS))))))))))))	
Comm	issioner for Patents		
P.O. Box 1450			
Alexandria, VA 22313-1450			

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In the Restriction Requirement mailed March 29, 2006, with a period for response extending to May 1, 2006 (April 29th being a Saturday), the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 6, 8-25, and 32-34) and Group II (claims 26-31). Applicants elect to prosecute Group I, claims 6, 8-25, and 32-34, characterized by the Examiner as drawn to a method, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: May 1, 2006

David M. Longo Reg. No. 53,235